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PATENT  
3430-0140P



IN THE U.S. PATENT AND TRADEMARK OFFICE

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TC 1700

Applicants: Byung Yong AHN

Conf.: 3449

Serial No.: 09/747,928

Group: 1765

Filed: December 27, 2000

Examiner: B. Tran

For: DRY ETCHING METHOD AND APPARATUS FOR USE IN THE LCD  
DEVICE

**RESPONSE TO EXAMINER'S RESTRICTION REQUIREMENT**

Assistant Commissioner for Patents  
Washington, DC 20231

September 17, 2002

Sir:

In response to the Examiner's Restriction Requirement dated August 30, 2002, the following election and remarks are respectfully submitted in connection with the above-identified application.

**IN THE CLAIMS:**

Applicant hereby elects Group II consisting of claims 7-21 for initial examination in this application. This election is with traverse.

**REMARKS**

Applicant thanks the Examiner for the thorough consideration given the present application. Claims 1-23 are currently being prosecuted. The Examiner